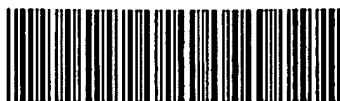


Search Notes



Application/Control No.

10/826,267

Examiner

David Y. Chung

Applicant(s)/Patent under Reexamination

KIM ET AL.

Art Unit

2871

SEARCHED

| Class | Subclass | Date | Examiner |
|---------|----------|-----------|----------|
| 349 | 129 | 2/21/2005 | DC |
| 349 | 130 | 2/21/2005 | DC |
| 349 | 122 | 2/21/2005 | DC |
| 349 | 138 | 2/21/2005 | DC |
| 349 | 139 | 2/21/2005 | DC |
| updated | updated | 8/5/05 | DC |
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INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|--------|----------|
| same | same | 8/5/05 | DC |
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)

| | DATE | EXMR |
|---|-----------|------|
| EAST search report | 2/21/2005 | DC |
| Consulted Ken Parker regarding allowable subject matter | 2/21/2005 | DC |
| | 8/5/05 | P |
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